

Docket No.: 50103-537

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
KURATAKA, NOBUO, et al.	:	
	:	
Serial No.: Unassigned	:	Group Art Unit: Unassigned
	:	
Filed: Concurrently Herewith	:	Examiner: Unassigned
	:	
For: METHOD FOR PROTECTING SURFACE OF STAMPER/IMPRINTER DURING MANUFACTURE THEREOF		

APPLICATION DATA SHEET

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following inventor bibliographic information is submitted in accordance with
the provisions of 37 CFR 1.76 and MPEP 6 01.05.


1. Name: Nobuo Kurataka
Residence: Campbell, California
Citizenship: Japan
Post Office Address: 502 Railway Avenue, Apt. #314, Campbell, Ca 95008
2. Name: Christopher J. Formato
Residence: Brentwood, California
Citizenship: US
Post Office Address: 369 Dante Court, Brentwood, CA 94513

Serial No.: Unassigned

3. **Name:** Hong Ying Wang
 Residence: Fremont, California
 Citizenship: China
 Post Office Address: 43504 Ocasco Corte, Fremont, CA 94539

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Aaron Weisstuch, Ph.D.
Registration No. 41,557

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 BPC:rrh
Facsimile: (202) 756-8087
Date: June 25, 2003